

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

the Application of: **Masayuki KURUHASHI et al.**

Group Art Unit: **2813**

Application Number: **10/696,775**

Examiner: **Stephen W. Smoot**

Filed: **October 30, 2003**

Confirmation Number: **7971**

For: **METHOD FOR FABRICATING A SEMICONDUCTOR DEVICE
INCLUDING THE USE OF A COMPOUND CONTAINING
SILICON AND NITROGEN TO FORM AN INSULATION FILM
OF SiN, SiCN OR SiOCN**

Attorney Docket Number: **032076**

Customer Number: **38834**

AMENDMENT TRANSMITTAL

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

July 18, 2006

Sir:

Transmitted herewith is an Amendment in the above-identified application. The fee has been calculated as shown below.

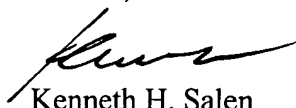
					SMALL ENTITY		OR	OTHER THAN SMALL ENTITY	
	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NUMBER PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDI- TIONAL FEE		RATE	ADDI- TIONAL FEE
Total (37 CFR 1.16(c))	0	Minus	0	= 0	X \$25		OR	X\$50	0.00
Independent (37 CFR 1.16(b))	7	Minus	6	= 1	X \$100		OR	X\$200	200.00
FIRST PRESENTATION OF MULTIPLE DEPENDENT CLAIM (37 CFR 1.16(d))					+ \$180		OR	+ \$360	0.00
					TOTAL ADD'L FEE			TOTAL ADD'L FEE	200.00

XX Enclosed please find our check in the amount of \$200.00 for the additional claims fee in connection with this Amendment.

The Commissioner is hereby authorized to charge payment for any additional fees associated with this communication or credit any overpayment to Deposit Account No. 50-2866.

Respectfully submitted,

WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP


Kenneth H. Salen

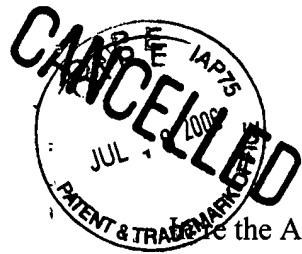
Attorney for Applicants

Registration No. 43,077

Telephone: (202) 822-1100

Facsimile: (202) 822-1111

KHS/rf



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re the Application of: **Masayuki FUJIEASHI et al.**

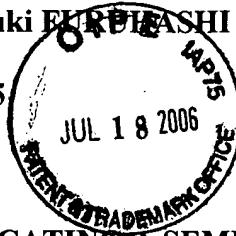
Group Art Unit: **2813**

Application Number: **10/696,775**

Examiner: **Stephen W. Smoot**

Filed: **October 30, 2003**

Confirmation Number: **7971**



For: **METHOD FOR FABRICATING A SEMICONDUCTOR DEVICE
INCLUDING THE USE OF A COMPOUND CONTAINING SILICON
AND NITROGEN TO FORM AN INSULATION FILM OF SiN, SiCN
OR SiOCN**

Attorney Docket Number: **032076**

Customer Number: **38834**

AMENDMENT UNDER 37 C.F.R. §1.114

MAIL STOP RCE

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

July 18, 2006

Sir:

In response to the Office Action dated January 19, 2006, the response date of which having been extended by three months to July 19, 2006, Applicants amend the claims as follows and submit the following remarks.

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 12 of this paper.